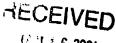


O NOT ENTER



Jan 1 6 2004

TC 1700 RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 1722

PATENT

AF/172

Customer No. 22,852

Attorney Docket No. 04329.2230

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	Application of:)
Kenji HASHIMOTO) Group Art Unit: 1722
Application No.: 09/503,170) Examiner: R. Davis
Filed:	February 14, 2000))) MAIL STOP AF
For:	RESIN ENCAPSULATING APPARATUS AND METHOD USED IN A MANUFACTURE OF A SEMICONDUCTOR DEVICE))))
Comm	hissioner for Patents	

Corres. and Maii

Alexandria, VA 22313-1450 Sir:

P.O. Box 1450

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed October 21, 2003, the period for response to which extends through January 21, 2004, and pursuant to 37 C.F.R. § 1.116, Applicant proposes that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 8 of this paper.

FINNEGAN HENDERSON FARABOW GARRETT & DUNNERLL

1300 | Street, NW Washington, DC 20005 - 202.408.4000 Fax 202.408.4400 www.finnegan.com